

ATM-1100G

Full Automatic Wafer Protective Tape Laminating Machine

Outline

The ATM-1100G is the ideal system for laminating tape to wafers, before the backgrind process.

Features

- Special controlled cutting along the wafer contour after tape lamination ensures the production of uniform and high precision taper laminates free from bubbles.
- Special controlled cutting provides notched wafers and all-angle secondary flat positioned wafers.
- •Ensures lower running cost.
- •Without providing tape tension onto wafer, wafer does not have any stress after Back Grinding.



Specification		ATM-1100G
Throughput		90wafers/hour(Depend on data setting)
Wafer Size		4.5.6.8 inch
Tape Width		130~230mm
Utilities	Power	AC100V 50/60Hz Single phase 1.5KVA
	Air	0.5Mpa 90Nl/min
	Vacuum sourse	—74Кра
Dimensions		$D1,140 \times W1,200 \times H1,645$ mm Excuanding signal tower
Weight		Approx 500kg

 $System\ appearance\ and\ specifications\ are\ subject\ to\ change\ without\ prior\ notice\ from\ the\ supplier.$

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